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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:) PATENT APPLICATION
Inventors:	Hirohiko Nishiki, James M. Atkinson and Yukihiko Nakata)
Serial No.:	Not Yet Assigned) Attorney Docket No.) SLA 0452
Filed:	Herewith)
Title:	SYSTEM AND METHOD FOR ETCHING RESIN WITH AN OZONE WET ETCHING PROCESS))))

Hon. Commissioner for Patents Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. §1.97

Sir:

Listed on attached Form PTO-1449 is information submitted pursuant to 37 C.F.R. §1.56. A copy of each listed publication is submitted herewith.

Applicant respectfully requests that the listed information be considered by

the Examiner and made of record in the above-identified application

(Date) / / / () 2

Respectfully submitted

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